



PATENT
Docket No. 606402016900

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Akira SUZUKI *et al.*

Serial No.: 10/784,888

Filing Date: February 24, 2004

For: MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE WITH
CHAMFERING (as amended)

Examiner: Bradley Smith

Group Art Unit: 2891

AMENDMENT UNDER 37 CFR 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Action mailed March 20, 2007, please amend this application as follows.

The listing of claims begins on page 2.

Remarks begin on page 6.

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~~01 FC:1251~~
02 FC:1201

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